

MS AF  
REPLY UNDER  
37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1752

PATENT  
2870-0179P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Tokuju OIKAWA Conf.: 2676  
Appl. No.: 10/058,028 Group: 1752  
Filed: January 29, 2002 Examiner: CHEA, THORL  
For: PHOTOTHERMOGRAPHIC MATERIAL

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REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

November 4, 2003

Sir:

In reply to the Office Action dated May 5, 2003, the due date for responding having been extended three months to November 5, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes List of Claims, Remarks and a Declaration under 37 CFR 1.132.